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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Michael A. Vyvoda et al.

For : WAFER SURFACE THAT FACILITATES
PARTICLE REMOVAL

Serial No. : 09/776,009

Filing Date : February 2, 2001

Hon. Commissioner
for Patents
Washington, D.C. 20231

TRANSMITTAL LETTER FOR
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Transmitted herewith is a Supplemental Information Disclosure Statement in the above-identified application.

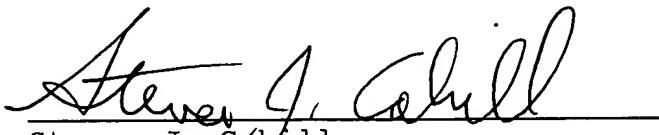
This Statement is submitted:

- within three months of the application filing date;
- more than three months from the application filing date but before the mailing date of the first Office Action on the merits.

In accordance with 37 C.F.R. § 1.97, submission of this Statement requires no fee. However, if for any reason a fee is due, the Commissioner is hereby authorized to charge payment of any fees required in connection with this Information Disclosure Statement to Deposit Account

No. 06-1075. A duplicate copy of this letter is transmitted herewith.

Respectfully submitted,


Steven J. Cahill
Steven J. Cahill
Registration No. 44,578
Attorney for Applicants

FISH & NEAVE
Customer No. 1473
1251 Avenue of the Americas
New York, New York 10020-1104
Tel.: (650) 617-4000

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02-21-2001

LILY X. JIANG


Lily X. Jiang
Signature of Person Signing



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Hon. Assistant Commissioner
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Washington, D.C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.56, 1.97, and 1.98, applicants wish to call the attention of the Examiner to the following documents:

U.S. Patent Application

09/560,626

N. Johan Knall

04/28/2000

This document is listed on the accompanying Form PTO-1449 (submitted in duplicate) and a copy is enclosed herewith.

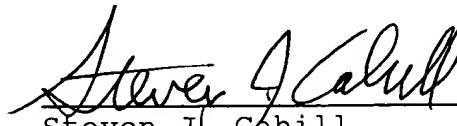
Consideration of the foregoing in relation to this patent application is respectfully requested.

Respectfully submitted,

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WASHINGTON, D.C. 20231, ON

02-21-2000
LILYX JIANG
J-XiLi
Signature of Person Signing

c/o


Steven J. Cahill
Reg. No. 44,578
Attorney for Applicants
FISH & NEAVE
1251 Avenue of the Americas
New York, New York 10020-1104
Tel.: (650) 617-4000